



Progress on a High Radiance Water Window Source for Imaging

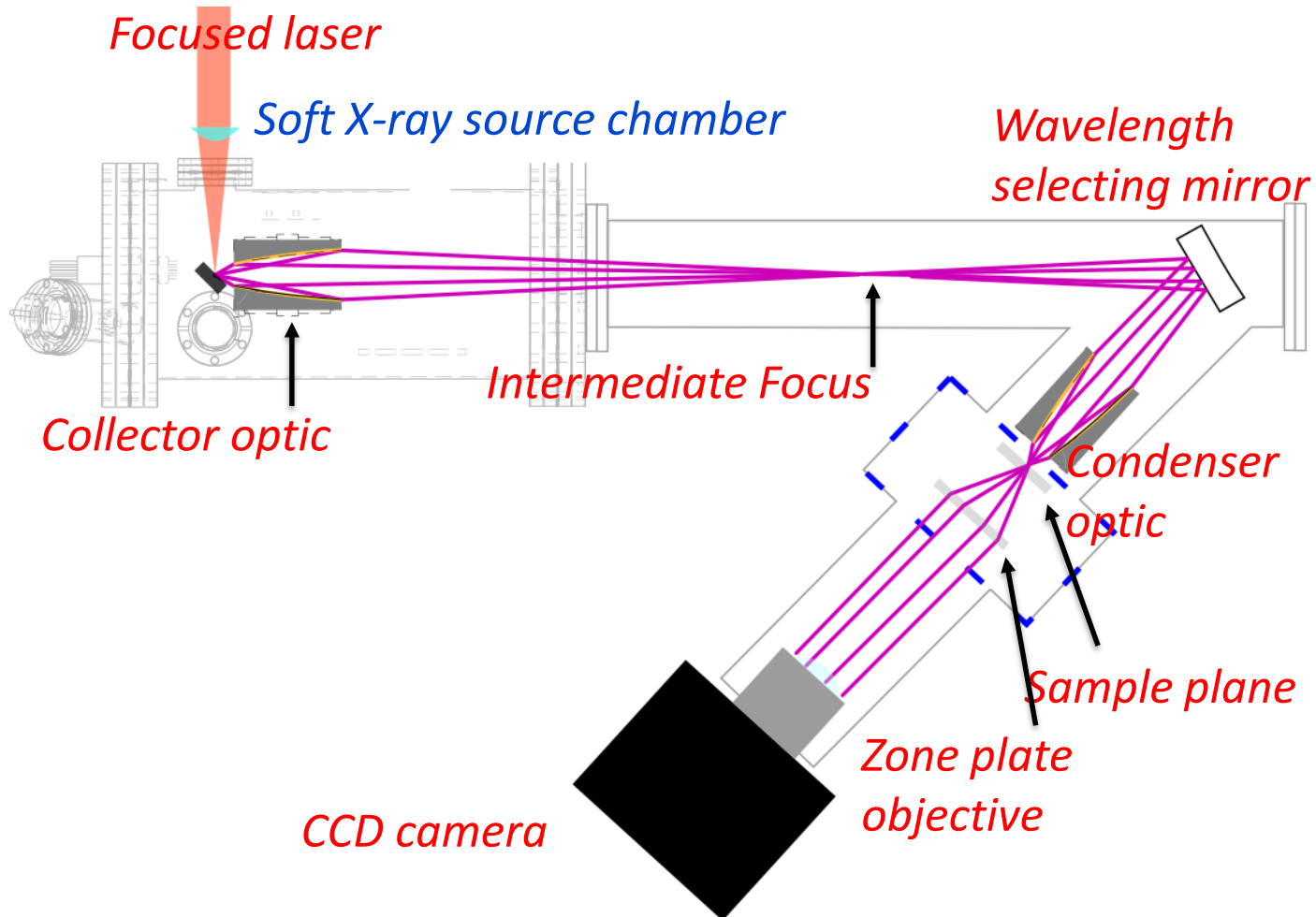
F. O'Reilly, W. Fyans, S. Brady, A. Manzoni, D. Rogers, J. Howard, D. Skoko, M. Donnellan, K. Wilson, J. Costello, I. Tobin, T. McEnroe, K. Fahy, P. Sheridan



SIRIUS

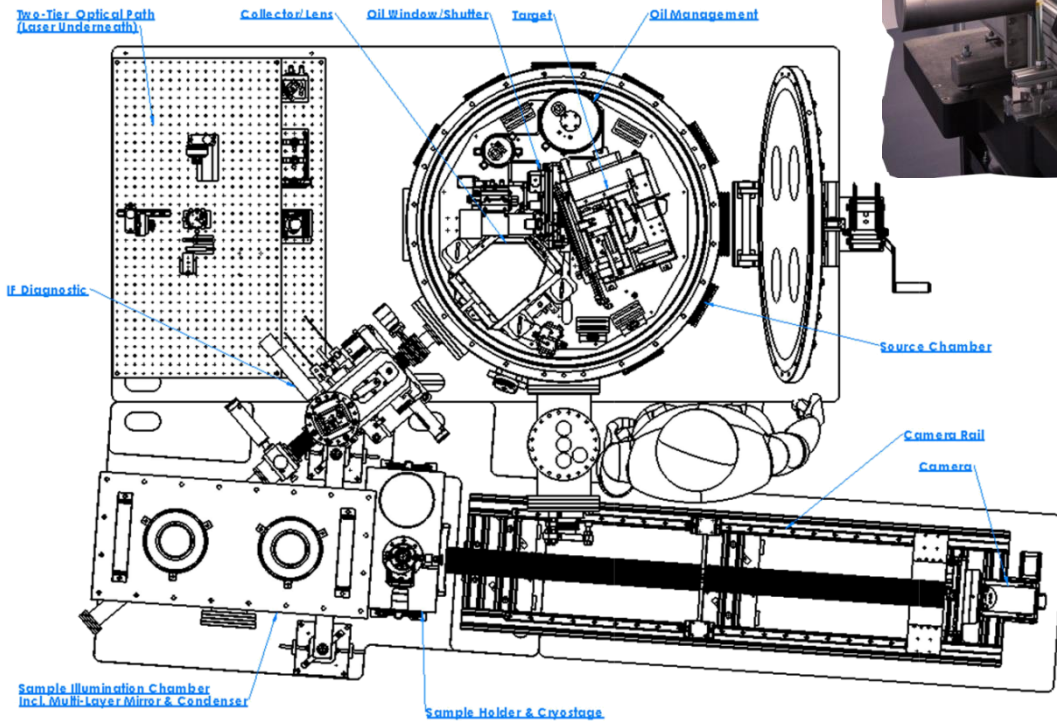
XT

Microscope Layout



SiriusXT microscope schematic.

Cryo Soft X-ray Microscope



Driving Laser



Edgewave IS

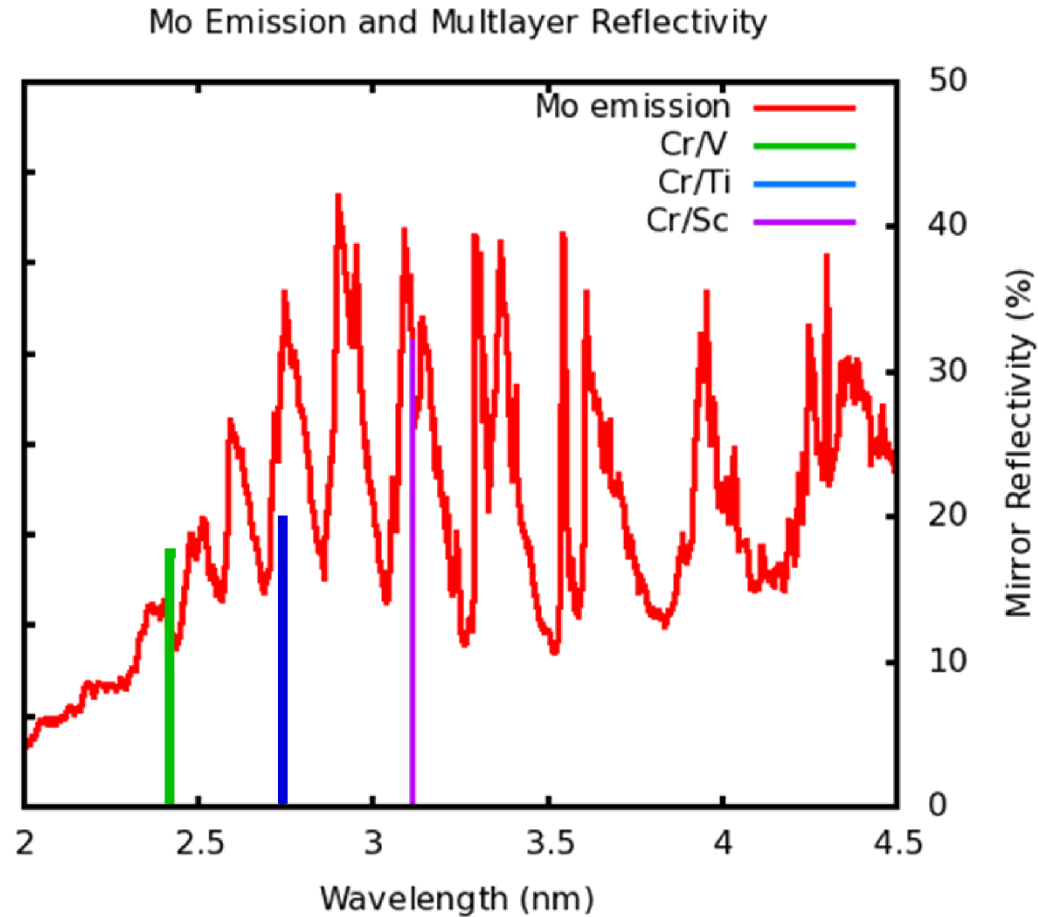
Pulse Energy 25 mJ

Pulse Length ~ 6ns

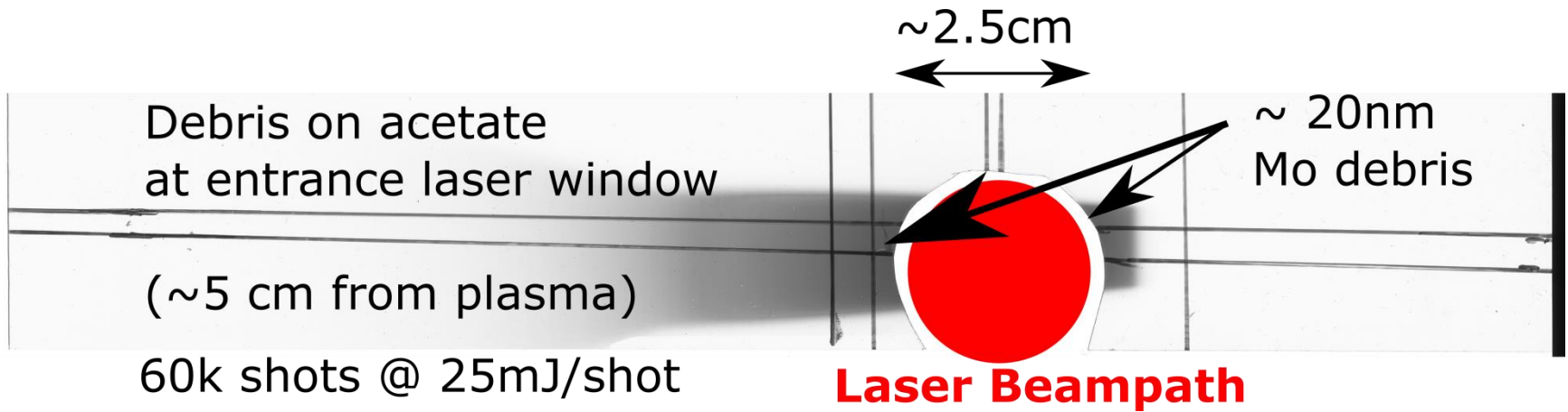
Rep Rate up to 5kHz

$M2 < 2$

Choice of Laser Target

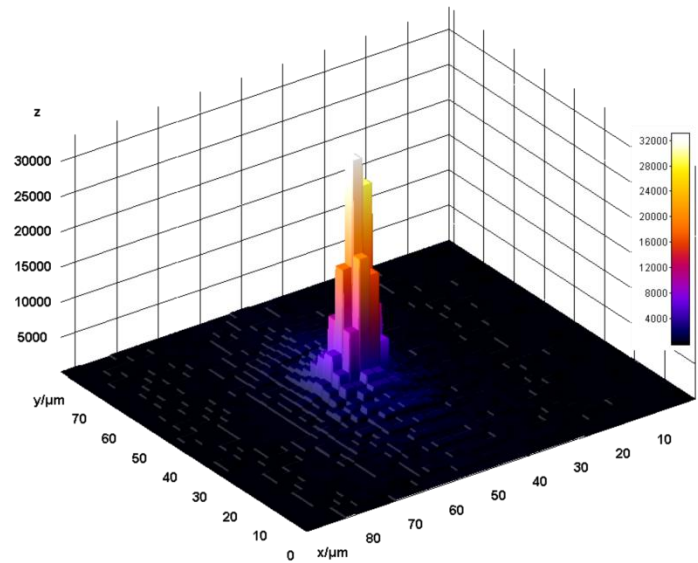
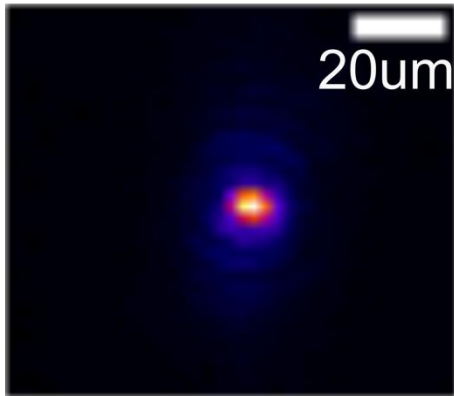


Wet Laser Optics



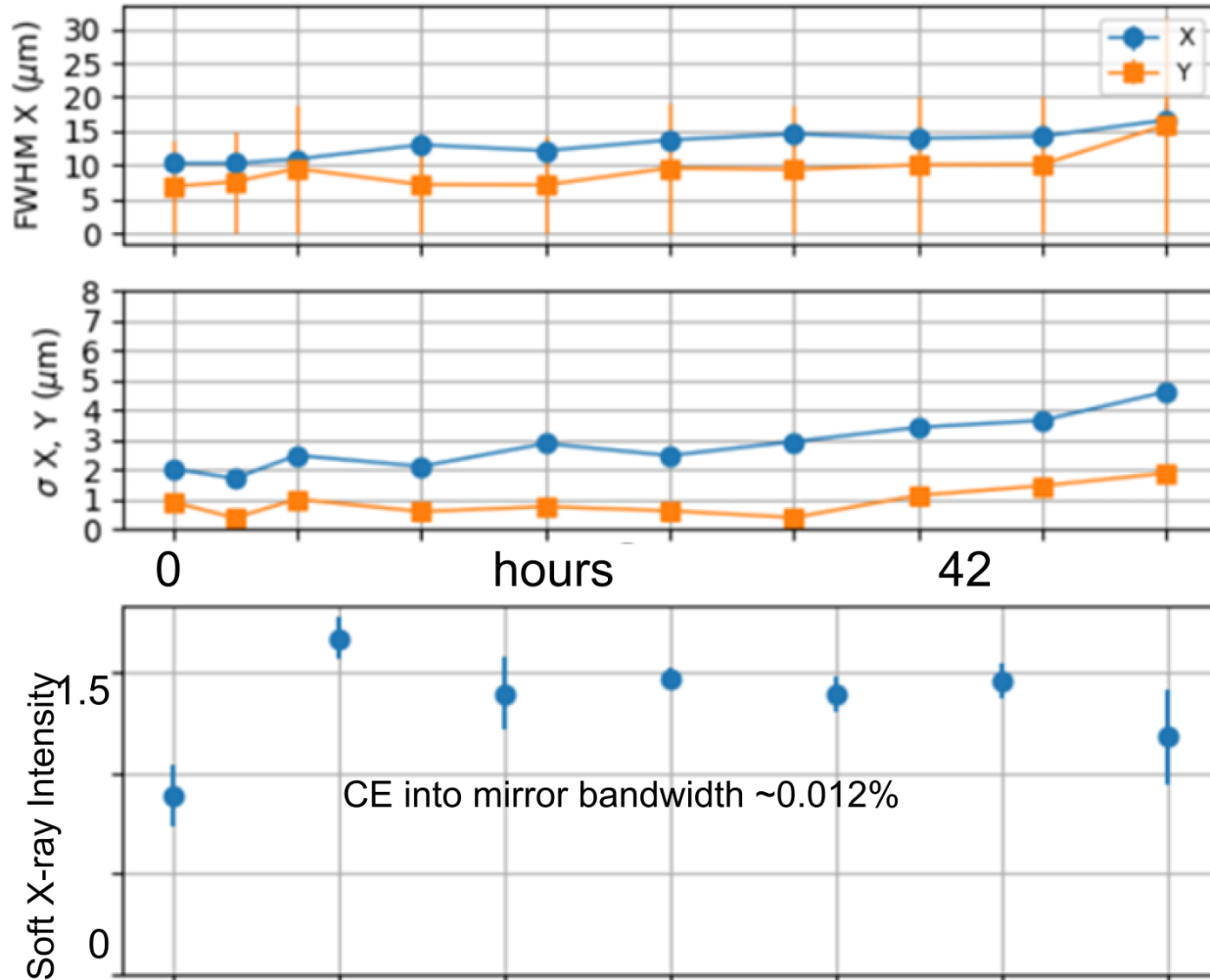
$\sim 20\text{ nm}$ of debris per minute at window at 1kHz laser rep rate

Laser Focus Through Liquid Window

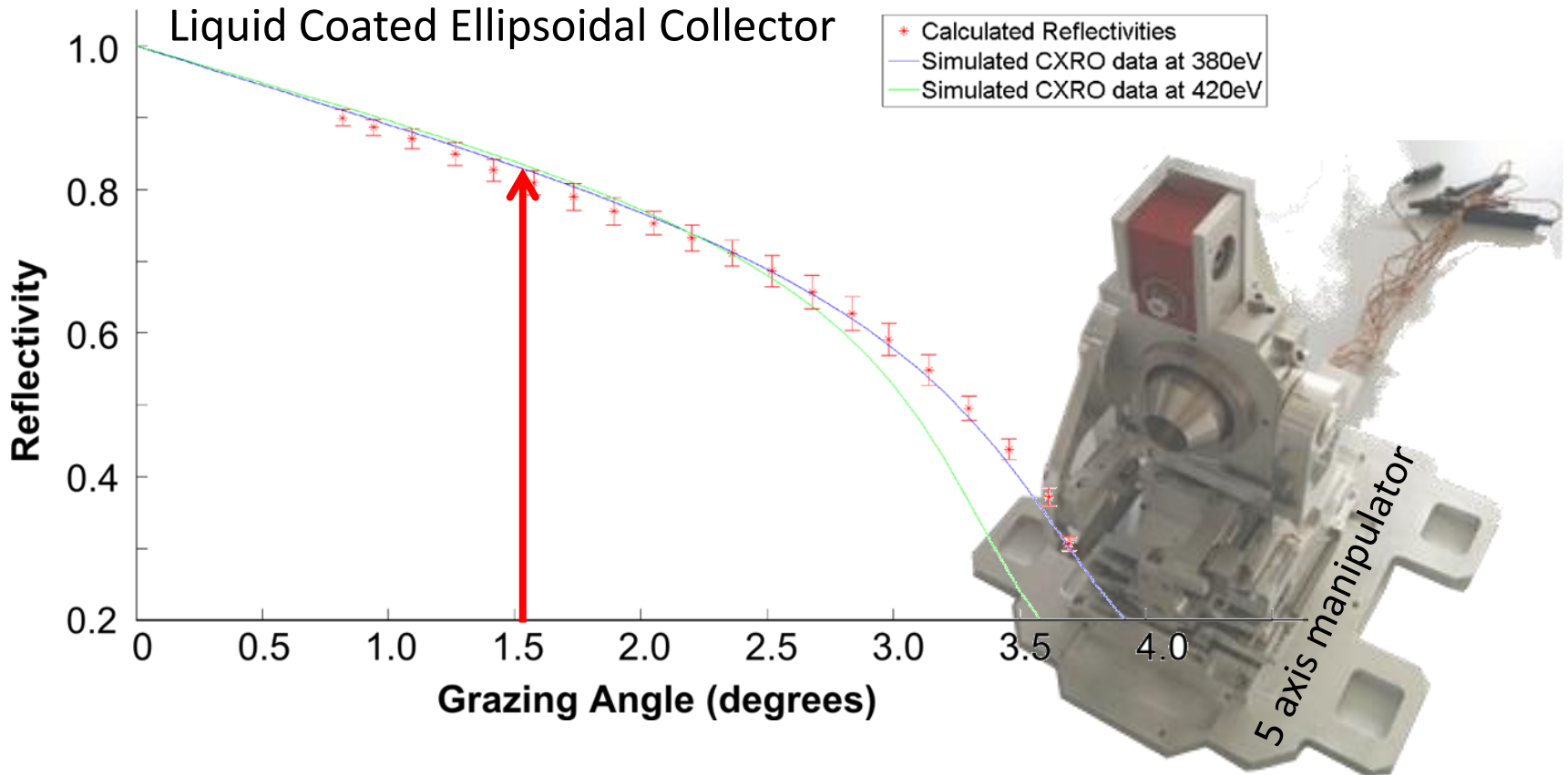


Laser Illumination NA ~ 0.25
1/e² diameter $\sim 10\mu\text{m} \times 13\mu\text{m}$

Output testing



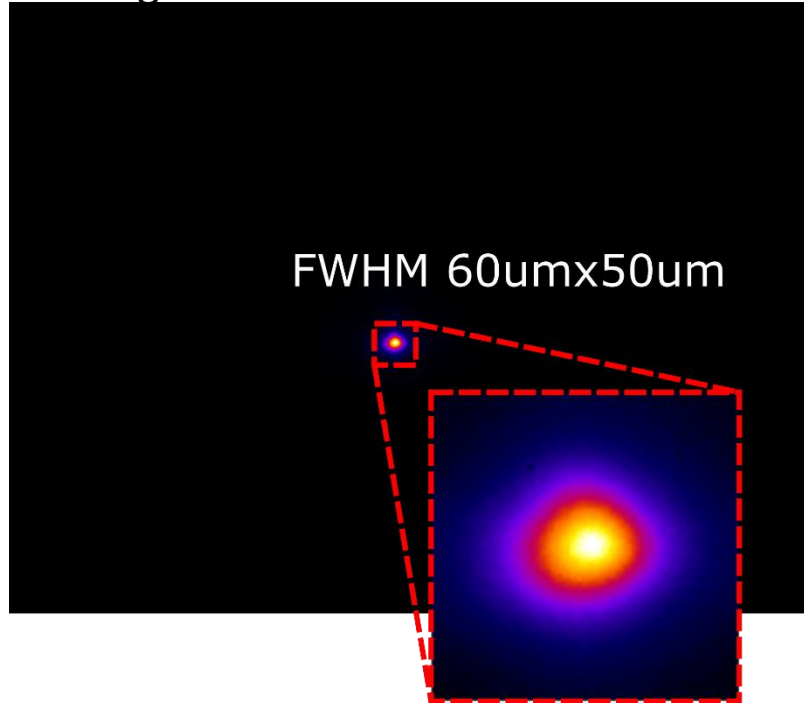
Soft Wet X-rays



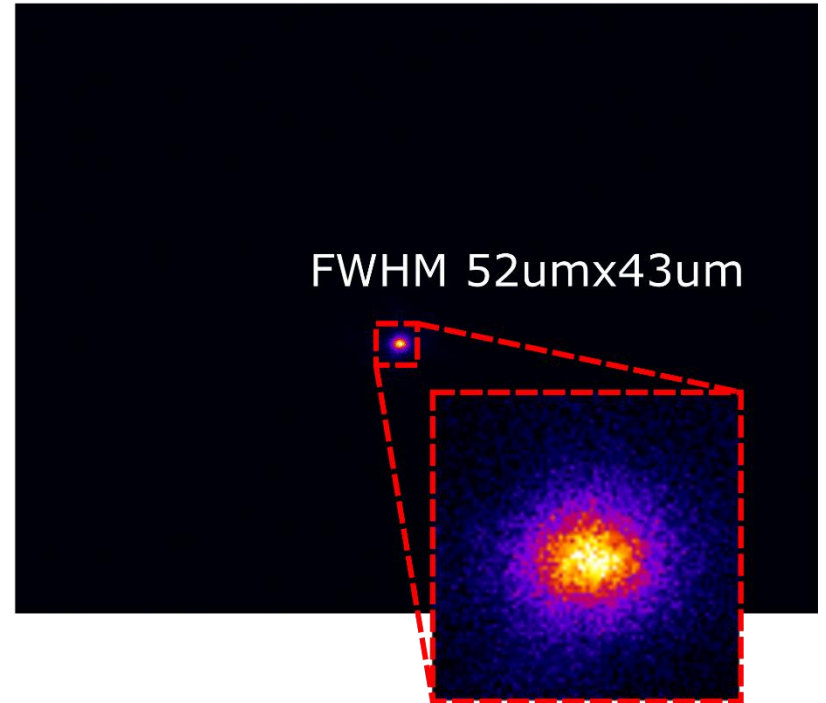
Focal Length = 1 m; Collection Fraction $\sim 0.04\%$)

Intermediate Focal Plane

Average



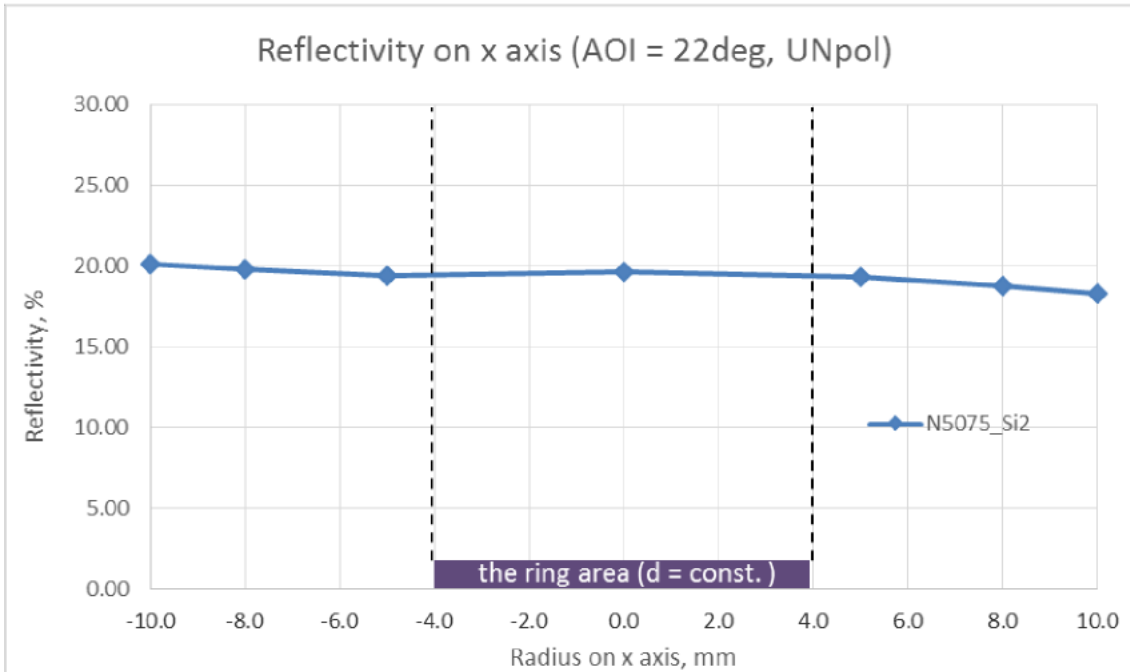
Single Frame



$\sim 15\%$ of photons in $36\mu\text{m} \times 36\mu\text{m}$ area useful for imaging

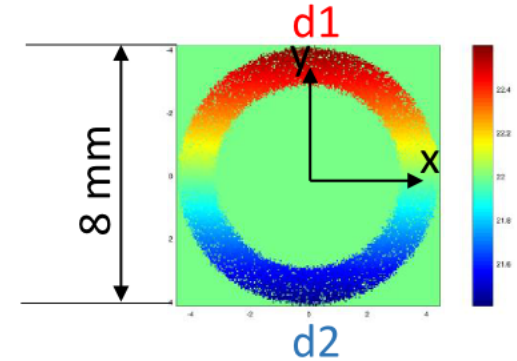
Wavelength Selecting Mirror

PTB results on mirrors (UNpol. reflectivity x axis):



Peak reflectivity within $-5 \text{ mm} < r < 5 \text{ mm}$:

Substrate N5075_Si2: $R_{\text{unpol}} = (19.48 \pm 0.17)\%$



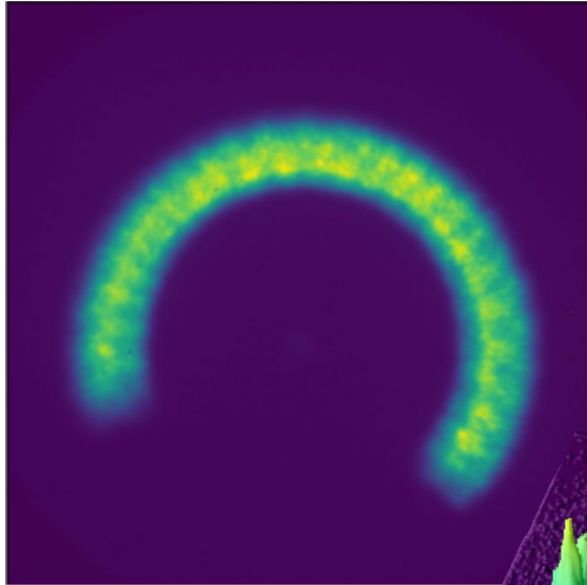
Reflectivity

20% at 2.73 nm

17% at 2.42 nm

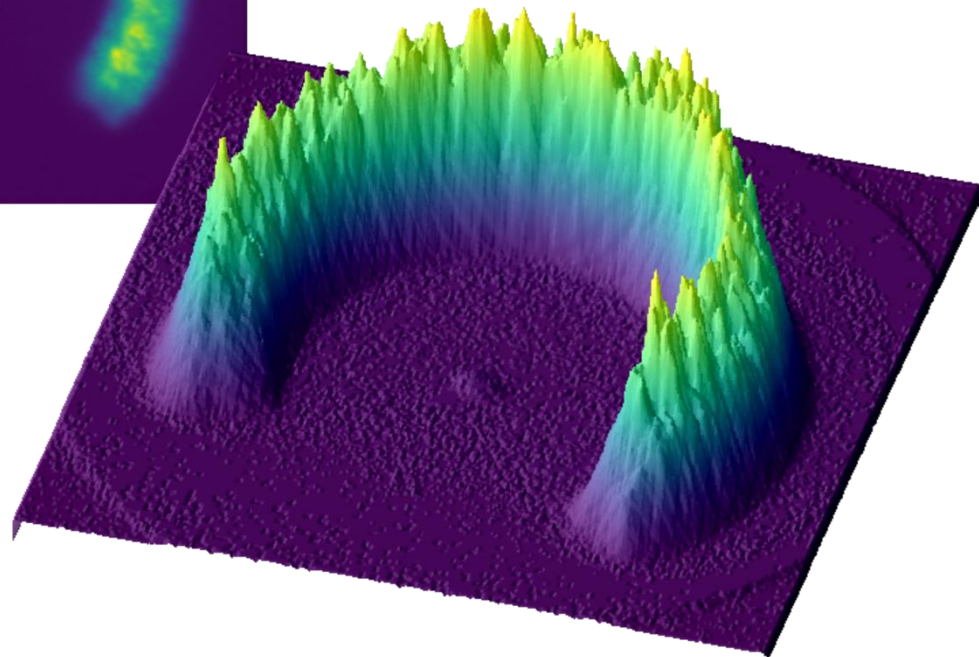
optiXfab.

Post Multilayer Annular

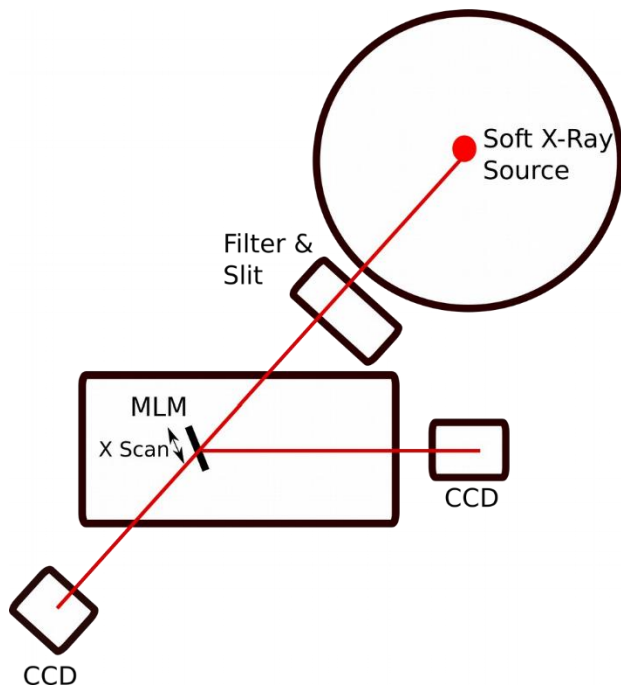


Photons after Multilayer
 $\sim 2E9/\text{sec}$

Uses graded MLM to maintain
 $\lambda/\Delta\lambda > 300$

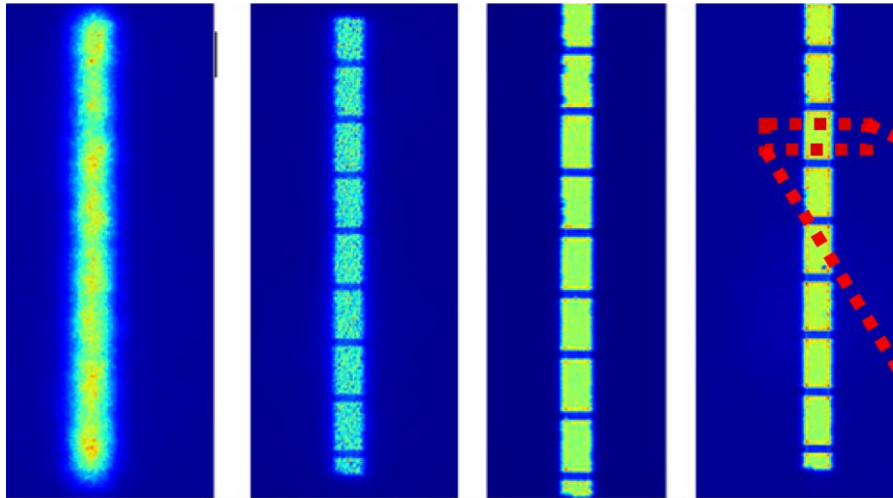


Mirror Scatter Metrology

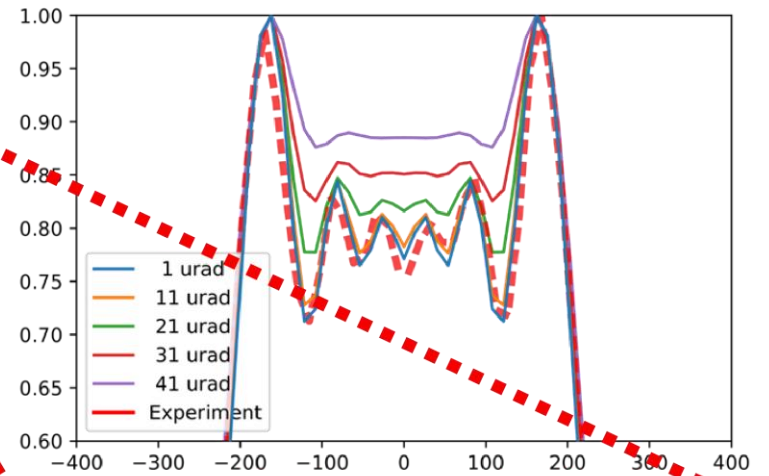


Element	Distance (mm)	Detail
Source	0	Braodband Mo plasma
Filter	730	0.3 um Cr
Slit	740	200 um wide
MLM	1440	
Cam 1	2040	Andor 13.5 um Pixel
Cam 2	2040	Andor, 13 um Pixel

MLM Substrate Selection



Slit Image Cross-section vs Mirror Scatter



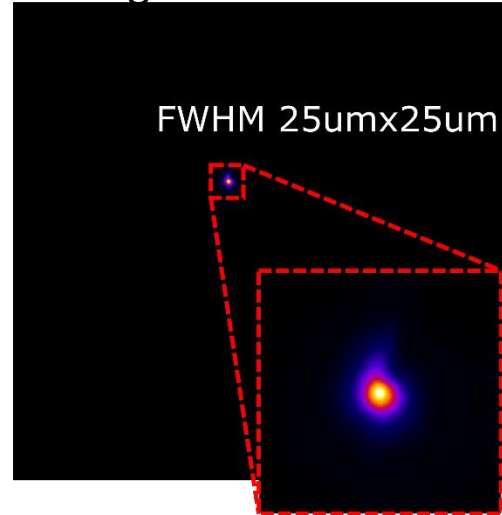
Sample Plane

Photons at Sample Plane:
~8E8 ph/sec (2.73nm – 20% MLM)

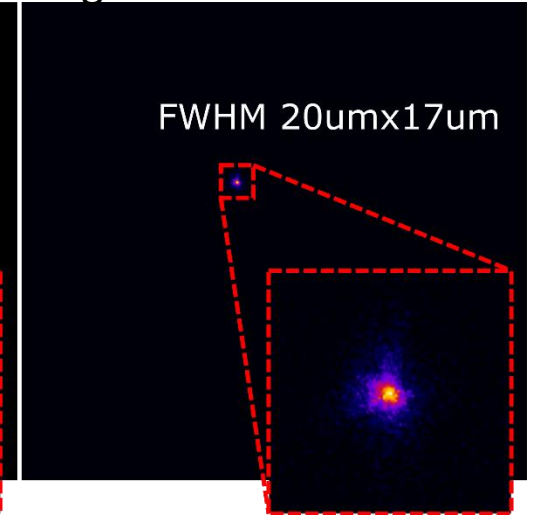
Condenser Focus:
Best 20 μ m x 17 μ m FWHM
Average 25 μ m x 25 μ m FWHM
(Stdev 1.6 μ m, 2 μ m X,Y)

> 7.5% of photons in 10 μ m x 10 μ m on average

Average



Single Frame



7.5% of
photons in 10 μ m x 10 μ m
on average

Acknowledgements

School of Physics Mechanical and Electronic Workshops
Gerd Schneider (and Group), Brian Rodriguez (and Group),
UCD Spectroscopy Research Group, RIT, OptixFab, Edgewave



Erasmus Mundus

A programme of the European Union



European Regional
Development Fund
Investing in your future